



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Jeong-kwan LEE et al.

Serial No. 09/982,086

Group Art Unit: 2811

Confirmation No. 6758

Filed: October 19, 2001

Examiner: Samuel A. Gebremariam

For: MICRO-LENS BUILT-IN VERTICAL CAVITY SURFACE EMITTING LASER

**LETTER TO THE EXAMINER REQUESTING CONSIDERATION OF TIMELY FILED  
INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

Further to a review of the instant application after our receipt of the Notice of Allowance mailed February 16, 2007, applicants have not received confirmation that the Information Disclosure Statements filed on May 4, 2004 and September 3, 2003 has been considered. Copies of the Information Disclosure Statements date stamped May 4, 2004 and September 3, 2003 are enclosed for the convenience of the Examiner. It is respectfully requested that the Examiner confirm consideration of the Information Disclosure Statements.

If the Examiner has any remaining issues to be addressed, it is believed that prosecution can be expedited by the Examiner contacting the undersigned attorney for a telephone interview to discuss resolution of such issues.

Respectfully submitted,

STEIN, MCEWEN & BUI LLP

Date:

2/27/07

By:

Howard I. Levy  
Registration No. 55,378

1400 Eye Street, NW  
Suite 300  
Washington, DC 20005  
Telephone: (202) 216-9505